




PATENT

IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicants: Young Hee MUN, et al.)	I hereby certify that this paper is being
)	deposited with the United States Postal
Serial No.: 10/699,438)	Service with sufficient postage as first
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Filed: October 31, 2003)	Mail Stop Amendment, Commissioner for
)	Patents, P.O. Box 1450, Alexandria,
Title: SILICON WAFER AND)	Virginia 22313-1450, on the date shown
METHOD OF FABRICATING)	below.
THE SAME)	
)	November 6, 2006
Group Art Unit: 2822)	
)	
Examiner: GUERRERO, Maria F.)	Andrew M. Lawrence
)	Registration No. 46,130
Attorney Docket No.: 29936/39510)	Attorney for Applicants

AMENDMENT "C"

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the official action dated May 5, 2006, please amend the above-identified patent application as set forth herein.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.